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Research on Stable, High-Efficiency, Large-Area Amorphous Silicon Based
Modules - Task B

Final Subcontract Report 1 March, 1989 - 28 February, 1990

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a**t** the abo**v**e ad**d**ress. I

SUMMARY

Objectives

The primary objective of this contract is to develop processes for the fabrication of stable, high-efficiency single-junction and tandem cells and modules based on thin film silicon: hydrogen alloys The focus of the effort at Siemens Solar Industries, (TFS) . formerly ARCO Solar, Inc., is the development of a four-terminal hybrid tandem junction consisting of a copper indium diselenide (CIS) bottom circuit and a semitransparent TFS top circuit, which is illustrated in Fig. 1. The glass/glass package provides long term environmental durability. The front ZnO electrode to the TFS device allows both a gridless geometry, minimizing module shadowing losses, and an optical antireflection stack in conjunction with the front glass to promote optical coupling of the light into the module. For light that is transmitted through the TFS device, the back TFS ZnO electrode in conjunction with the clear optical polymer coupling layer (typically ethylene vinyl acetate) and the front ZnO electrode to the CIS minimize reflection (less than 4% due to these interfaces) and absorption losses and assist entry of the light into the CIS absorber layer.

The principal tasks of the project are to prepare and characterize TFS and CIS for uniform deposition over 900 cm², to investigate ohmic contacts, transparent conducting layers, and textured light trapping layers, and to develop and demonstrate thin film modules over 900 cm² with photostability. In Phase III of the project, a thin film module with 13% conversion efficiency over 900 cm² and

TFS/CIS tander module structure. $Fig. 1.$

photostability was to be demonstrated. However, due to lack of funds, the program was canceled at the end of Phase II. report presents the technical progress for Phase IIB and represents m the final technical report for the contract.

Discussio**n** I

Discussion

W**o**rk **du**r**i**ng P**h**a**se I** (J**u**l**y** 1**987** ' **Au**g**ust 1988) o**f **thi**s **co**n**t**rac**t** addressed devel**o**pment of the basic film deposition, junction formation, and patterning techniques necessary to fabricate
high-efficiency cells and modules [1]. Module research during high-efficiency cells and modules [1]. Phase IIA (September 1988 - February 1989) focused on transferring the technology to large areas (0.4 m^2) for both TFS and CIS. Film and junction uniformity have been tested on 4140 cm² substrates. CIS and semitransparent TFS modules with aperture areas near 3900 cm² have been developed [2]. Efforts during Phase IIB (March 1989 - February 1990) have been on the transfer of high efficiency thin film processing to the Siemens Solar f**a**cility in Camarillo, improving the performance of 0.4 m² thin film modules, developing large area tandem module packaging, and demonstrating 0.4 m^2 , 4-
terminal TFS/CIS laminated and framed thin film tandem modules.

The thin film single junction and tandem cell and module performance results achieved during the contract are summarized in m Tables 1 through 5. During Phase I, a 15.6% active area efficient TFS/CIS tandem cell was demonstrated using a 10.3% semitransparent TFS and a 12.4% efficient CIS cell. In addition, a 12.3% aperture area efficient, 843 cm² 4-terminal TFS/CIS module was measured using a 7.7% efficient semitransparent TFS module and a 7.6% efficient CIS module. The **T**FS-filtered **CI**S module**'co**ntributed 2.7% efficiency to the tandem output, which is 35% of its stand-alone
performance. The filtered CIS module output is primarily defined performance. The filtered CIS module output is primarily defined by its lower short-circuit current, which is 37% of its unfiltered
value. During Phase I, a 3.5 cm², 14.1% active area efficient $\frac{1}{2}$ no/thin C₃/_c, $\frac{1}{2}$ and $\frac{1}{2}$ and $\frac{1}{2}$ and $\frac{1}{2}$ $\$

and 0.677 fill factor \overline{B} . If \overline{B} fill factor \overline{B}

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Emphasis during Phase II was on large area thin film module development, resulting in substantial performance achievements over large areas. A 33.2 watt (8.4% efficient), 3970 cm² aperture area
TFS module with a white back reflector was demonstrated. Without TFS module with a white back reflector was demonstrated. the white back reflector, the semitransparent TFS module measured 3**0**.2 watts **o**r 7**.**6% efficient. Placing a laminated 31.6 watt, 8.1% efficient CIS module underneath this TFS module, with an air gap between the two modules, produced **1**1.2 watts or 2.9% over a 3883 Thus, the 4-terminal tandem power output is 41.4 watts, translating to 10.5% aperture efficiency. The TFSnfiltered CIS power ratio of 0.35 is controlled by the \blacksquare filtered to unfiltered CIS power ratio of 0.35 is controlled by the current ratio of 0.38. Subsequently, a 37.8 watt (9.7% aperture effi**c**iency) CIS module has also been demonstrated with a 39**0**5 **c**m 2 aperture area.

 iv

Progress has been made on environmentally durable module packaging techniques. A glass/glass module lamination with a reaction tandem module changed less than 14% after 576 days of continuous outdoor exposure. The CIS subcircuit showed no loss. laminated CIS modules are within 5% of their original output power
after 470 days at the SERI outdoor photovoltaic test site.

Future performances of 3900 cm² aperture-area single-junction and
tandem modules have been modeled, and module powers over 50 watts (13%) for CIS and over 65 watts (17%) for TFS/CIS tandems are predicted.

I after 470 days at the SERI outdoor photovoltaic test site.

Conclus**ions**

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Film deposition and patterning processes have been successfully extended to 0.4 m^2 substrates. Large area module performance, which is presently in the 10% efficiency range, clearly confirms the scalability of thin film PV processing. TFS module stability, influenced both by Staebler-Wronski effects and by local defects,
has been improved by careful process control and handling. CIS has been improved by careful process control and handling. module stability is encouraging. Progress has been made on environmentally durable packaging for single-junction and tandem **II** modules. Future performances of 3900 cm² aperture-a single-junction and tandem modules have been modeled, and module power over 50 watts (13%) for CIS and over 65 watts (17%) for **IFS/CIS tandems are predicted.**

Key achievements of the contract are summarized below:

- **i** Key achieved all shipping for uniform lower • Achieved all objectives for uniform, large-area, high performance CIS and TFS semiconductor films.
	- Developed large area deposition of doped ZnO films with resistivities as low as 5×10^{-4} Q-cm and high optical quality.
	- **i** Developed modeling and analysis of TFS and CIS cells and modules to assess mechanisms controlling PV performance.
- **I** photocarright interface rection as important to the suppression of V and \bullet Identified photocarrier recombination in the front $p-i$ interface region as important to the suppression of v_{oc} and fill factor in TFS devices.
- **In the Demonstrated a 10.8%, 3.9 cm 20141 area semitransparent TFS** cell with no optical back reflector. This is equivalent to
- l 11.9% efficiency for TFS cells with back optical reflectors. • Developed thin film module patterning technology to achiev 254 **p**m interconnects, which results in only 5% active module **I** interconnect scribes. area loss. This was achieved by improving registration of the

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• Demonstrated that localized defects significantly influence **i** TFS module performance and photostability.

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® Identified and resolved several thin film module processing **R** problems including substrate contamination, source material contamination, parts handling, and thin film deposition

control. **I**

• Accomplished several world performance records:

- **•** Demonstrated excellent outdoor stability of @ncapsulated CIS **i** modules (within 5% after more than 470 days).
- Demonstrated 10.4%, 840 cm² TFS/CIS tandem module with only 14% performance loss after 576 days of outdoor exposure. CIS subcircuit showed no loss.
- **•** Explored large area (3900 cm 2) module processing with the **R** following demonstrated aperture efficiencies:

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Table 1. 4-terminal tandem cell performance^a.

a
Measured at ASTM air mass 1.5, global 100 mW/cm², 25^oc.

a
baperture area.
baperture area.

Table 3. 1x4 ft tandem module performance^a.

a
Measured at ASTM air mass 1.5, global 100 mW/cm², 25^oC.
Daperture area.

Table 4. TFS and CIS cell performance⁸.

^a Measured at ASTM air mass 1.5, global 100 mW/cm², 25°C.
^bBased on active area. For TFS, total area equals active area.

Table 5. TFS and CIS unlaminated module performance^a.

a
Measured at ASTM air mass 1.5, global 100 mW/cm², 25^oC.
D_{Aperture} area.

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(continued)

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I SECTION 1.0

CIS PROGRESS

1.1 INTRODUCTION

I 1.**1 INTR**O**DUCT**I**O**N

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i CIS *PRODUCTION CONTINUES*

Dur**in**g P**h**a**se II**B**, the co**pper **indium di**s**e**l**e**n**ide (CIS)** fa**b**r**ic**a**tio**n **I** Uactivities nfortunately, were permitting reloca**t**ed tdelays **o** the Siemens did not allow S**o**lar operation Camarillo offacility. the CIS facility until January 199**0**. This hindered our ability to fabricate CIS and thus ix4 ft tandem modules of thin film silicon:- **I** initial operation at the upgraded Camarillo facility, the unencapsulated CIS module performance increased by 2 watts to 37.8 watts (9.7% aperture efficiency) over a 3905 cm² aperture area.

II (9.7% aperture effects) over a 3905 cm 2 aperture area. The 3905 cm 2 aperture area. The 3905 cm 2 aperture are Maximum two-junction performance requires optimum high and low band
gaps, which modeling has identified to be in the 1.7 eV and 1.0 eV 14.1% (3.5 cm² active area) cell and 11.2% (938 cm² aperture area) and 9.7% (3905 cm² aperture area) module efficiencies [1,2]. The following sections describe the Phase IIB advancements in CIS large area modules, update results on long term outdoor exposure, and provide some perspectives on further advances in CIS modules.
Finally, the potential for 20% efficient CIS device technology is discussed. With the appropriate high band gap module, this CIS technology will further enhance the potential of thin film tandem PV technology.

1.**2 CIS** M**ODULE PE**R**FORMANCE**

In Phase I, initial CIS module development was pursued on 1 ft² sizes, which resulted in 10.5 watts (11.2% aperture area efficien-
cy) over a 938 cm² aperture area. The basic module design is **i** cy) over a 938 **c**m 2 aperture area. The basic module design is described in previous reports [**]**,2]. During P**h**ase IIA of this project, the processing technology developed on 900 cm² substrates was extended to 4140 cm^2 (128.6x32.2 cm) substrates to fabricate **II** substrate size is used in standard crystalline silicon and TFS 3900 cm² aperture-area modules (Fig. 1-1). The 4140 cm² glass products. The CIS module is divided into 53 cells, each measuring
0.577 cm wide including interconnects. Approximately 240 cm² of the substrate perimeter area is used for electrical buses and for edge sealing pads. This perimeter area is subsequently covered by
the module frame. The best large area CIS module performance achieved in Phase IIB was 35.8 watts (9.1% efficiency) over a 3916
cm² aperture area. After relocation of CIS processing to the After relocation of CIS processing to the Camarillo facility, initial operations have increased CIS module
power by 2 watts to 37.8 watts (9.7% efficiency) over a 3905 cm^2 aperture area (Fig. 1-2).

Fig. 1-1. Layout for
53-cell 1×4 ft CIS module.

Aperture Area = 3905 cm²
 V_{oc} = 23.9 volts
 I_{sc} = 2.51 amps
 F_F^{F} = 0.631 $= 23.9$ volts
 $= 2.51$ amps $= 0.631$ $\frac{v}{x}$ max $\frac{v}{x}$ $\frac{v}{x}$ $\frac{v}{x}$

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Voc (V) 25.5 23.9 26.9

 $Eff^b (%)$ 11.2 9.7 13.3
Power (W) 10.5 37.8 51.7

Table 1-1. Performance of CIS large area modules⁸.

,al0**0**m_/c**m** 2 **AST**M air m**ass** 1.5 g**to**b**a**L **s**pe**c**trum, 25%.

I Power (W) **,**, I0.5 _ 37.8 51.7

I Fill Factor 0.639 0.631 0.67

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Table 1-1 compares the performance of the best 940 cm² and 3900 cm² modules fabricated to date. At present the interconnect widths on 3900 cm² modules are 0.041 cm compared to 0.025 cm for the best 940 $cm²$ CIS module; therefore, the active area and I_{sc} are 3% lower than a linear extrapolation in aperture area predicts. Interconnect widths of 0.030 cm are expected to be achieved in the near future. The lower active area J_{sc} , V_{gc} cell, and fill factor shown in the table for the 3900 cm[.] modules are the combined result of lowe **I** is shunting on the larger areas. When these problems are minimize junction quality, lower ZnO uniformity, and pattern-induced the aperture-area efficiency previously demonstrated on 940 cm² CIS modules will yield 43.6 watts on 3900 cm² module areas.

I modules wi_l yield 43.6 watts on 3900 cm 2 module areas. Future 3900 cm² CIS module performance has been modeled assuming the junction characteristics of the 14.1% efficient 3.5 cm² CIS cell previously reported, 0.030 cm interconnect widths, and the contact resistances typically measured on 940 $cm²$ modules. The projection in Table 1-1 assumes that the module has uniform \blacksquare factor, 6 Ω /O ZnO sheet resistance, and 0.001 Ω -cm² interconnection contact resistance. The model projects that the performance of 3900 cm^2 modules will be 51.7 watts (13.3% aperture efficiency) when the junction efficiency previously demonstrated on small-area cells is realized on the larger area.

! 1.3 CIB MODULE STABILITY

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Module stability results are preliminary but are encouraging. Modules laminated with ethylene vinyl acetate (EVA) between a cover glass and a backing metal sheet show less than 5% change after more
than 470 days of continuous exposure at the SERI outdoor test site

i than 470 days of continuous exposure at the SERI outdoor test sites sites sites sites sites sites sites sites

Stability of CIS submodules after 470 days Fig. $1-3$. of outdoor exposure.

(Fig. 1-3) [3]. In production, the glass/glass CIS module laminate can be framed with a reaction injection molded (RIM) frame. A prototype glass/glass/RIM 3900 cm² module was measured at 33.75 watts at both SERI and Siemens Solar. Accelerated module life cycle testing indicates that further module packaging development Delamination between the top and bottom glass is is needed. evident for some modules. Reproducible edge sealing also needs improvements although excellent moisture sealing has been shown when the EVA cure level exceeds 90% in standard gel testing. The verification of CIS module stability is a major milestone in confirming the commercial viability of CuInSe, devices for high-power, low-cost PV applications.

TOWARD 20% CIS DEVICE TECHNOLOGY 1.4

This section addresses the efficiency limits of single-junction CIS-based alloy solar cells. CIS cell efficiencies of 20% and beyond are within reach with 45 mA/cm² J_{sc}, 600 mV V_{oc}, and 0.75 fill factor.

The highest CIS efficiency reported to date is 14.1%, achieved using the cell structure ZnO/thin CdS/CIS/Mo/glass [4]. The cell has a 41.0 mA/cm² J_{sc}, 508 mV V_{oc}, and 0.677 fill factor measured under 100 mW/cm² ASTM air mass 1.5 global spectrum [5].

Pursuit of high CIS efficiencies requires understanding the primary mechanisms controlling CIS device performance, especially photocarrier collection, junction rectification, and electrical resistance losses. For 100 mW/cm² ASTM air masc 1.5 global spectrum, the theoretical maximum CIS photocurrent $\sin 51$ mA/cm², which is the number of photons with energy greater than the CIS hand gap (assuming 0.95 eV). If all of these photons were absorbed by the CIS and made available to the external circuit at the CIS band gap energy, the efficiency would be dramatically high.
Unfortunately, physical principles prohibit this. The following sections examine these physical principles, discuss measurements of device performance, and identify areas for improvement.

I. **4**.**1 Photocurrent**

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timitations to achieving 51 mA/cm[.] J_{sc} in CIS arise from optical matrice in the matrice of matrice in a region of the matrice of reflection, unwanted optical absorption in front layers, incomplete optical absorption in the absorber layer, and incomplete minority carrier collection. For the 14.1% CIS cell, which has a 41.0 $mA/cm²$ J_{sc}, the spectral response is described by

$$
QE = (1-R) \times exp[-\alpha_{2n0} \times t_{2n0}] \times exp[-\alpha_{cds} \times t_{cds}] \times Eq. 1
$$

$$
[1-exp(-\alpha_{c1s} \times W_{c1s})/(1 + \alpha_{c1s} \times L_{c1s})]
$$

where R is the front reflection loss, α is the optical absorption coefficient [6] and t is the thickness of the respective layers, W is the depletion width, and L is the minority carrier diffusion length. Typical values are 0.4 pm for W and 0.5 pm for L. ZnO plasma absorption, evident at wavelengths longer than 900 nm, reduces J_{sc} by about 1 mA/cm², depending on the ZnO electron $concentrational$ carrier mobility $[4]$.

 \blacksquare will reduce optical reflection and plasma absorption losses enhancing J_{sc} by 1.5 mA/cm² to 42.5 mA/cm². Optical confinement by ^J reducing the CIS absorber thickness and using optical back reflectors will promote absorption of light in the active device region. In addition, improved minority carrier lifetime and/or the
use of minority carrier mirrors will increase long wavelength (greater than 900 nm) response of the cell.

Open-Circuit Voltage **1** 4. **2**

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The achievement of 508 mV V_{oc} is a result of reducing the CIS reverse saturation current. The CIS current-voltage dependence on temperature implies that the dominant junction loss mechanism is recombination [7]. Microshunts (microscopic local areas of
increased junction shunting) have been identified by optical-beami in**c**reased junction shunting) have been identified by optical-beam- induced current (OBIC) and electron-beam-induced current (EBIC) imaging [8,9]. Substantial spatial variations in electron

5

l response up to 0.I mm in size are also evident in these films.

Transmission electron microscopy (TEM) and energy dispersive X-ray analysis (EDX) have identified compositional and structural nonuniformities in the CIS layers [10]. In addition, intragrain and grain surface properties and both the CdS/CIS and Mo/CIS interfaces contribute to junction recombination. The CIS defect chemistry within the grains, at the grain surfaces, and at the junction and contact interfaces ultimately determines the limit to recombina-
tion. All of these are related to the processing of the device, All of these are related to the processing of the device, either through the quality of the feedstock materials or through the processing conditions.

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the processing conditions. J**I** The additions of alloy elements, such as Ga and S, can als increase V_{ac} by increasing the absorber layer band gap as long as heterojunction window layer also significantly impacts the V_{oc} and the minority carrier lifetime is not degraded. The nature of the h_{eff} is the virtual window $\frac{1}{2}$ in $\frac{1}{2}$ in particular also significantly improved the VoL and cell performance. High band gap II-VI and chalcopyrite window layers are options. Replacing CdS with thin ZnSe has already shown promise in preliminary studies, giving 10% efficiency, 40.1 mA/cm² J_{sc}, 391 mV V_{oc}, and 0.641 fill factor [11].

Continued optimization of processing conditions is expected to **I**- achie e 550 to 570 mv y_{00} . Modifications to the material and

interfaces will achieve Voc of 600 mV and higher. **I**

_.4.**3 Fill Factor**

 T_{ref} fill factor is determined by the cell $\frac{1}{2}$ $\frac{1}{2}$ and the electrical **I** resistance losses. Measurements of the fill _actor dependence on cell geometry, light intensity, and temperature for the 12% CIS cell structure have been described elsewhere [7]. For the 14.1% CIS cell, its 0.677 fill factor will increase to 0.723 by reducing series resistance, primarily caused by the 13 Ω/\square front ZnO layer. Increasing the cell Vo**c** to 525, 550, 575, and 600 mV will increase fill factor to 0.729, 0.737, 0.744, and 0.751 respectively. **I**

1.**4**.**4 Co**n**clusions I**

The prac**ti**ca**l li**m**i**ts t**o** effi**cie**n**c**y are **t**he **st**r**uct**ura**l** an**d elect**ronic quality of the device layers and their interfaces, which are controlled by the processes used to form them. CIS cell efficiencies of 20% and beyond are within reach with 45 mA/cm² J_{sc}, 600 mV
V_{oc}, and 0.75 fill factor.

 α

operation at the upgraded Camarillo facility, the unencapsulated **I**

DISCUSSION 1.5

During Phase IIB, the CIS fabrication activities were relocated to \blacksquare the Siemens Solar Camarillo facility. Unfortunately, permitting delays did not allow operation of the CIS facility until January **I** 1990. This hindered our ability to fabricate CIS and thus 1×4 ft TFS/CIS tandem modules. In spite of these *delays, in initial*
operation at the upgraded Camarillo facility, the unencapsulated

CIS module performance increased by 2 watts to 37.8 watts (9.7%) aperture efficiency) over a 3905 cm^2 aperture area. Table 1-1 lists the performance parameters for the 37.8 W CIS module. The **35.8 W CIS module described in the previous report [2] had a 23.5** V V_{oc}, 2.54 A I_{sc}, and a 0.60 fill factor. Thus, the 5% increase in module power resulted primarily from a 5% improvement in fill factor (from 0.60 to 0.63) due to reduced series and shunt resistance losses. Although detailed analysis of the resistance mechanisms would require destructive testing of the module, the improved fill factor is expected to result from new patterning equipment developed outside of this contract which allows the interconnects to be scribed in one step. The previous patterning
equipment required a step-and-repeat sequence to cover the 127 cm length of the interconnects in four steps.

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High efficiency tandem PV modules depend upon the necessary
contributions from the high and low band gap module components. **i** cis has been demonstrated to be an important low band gap cel technology with 14.1% measured active area efficiency and the potential of over 20% efficiency. More significantly, it is a proven module technology that has been scaled quickly to 37.8 watts (9.7% aperture efficiency). Modeling, based upon demonstrated over 3900 cm aperture areas. As described above, several research tasks remain to optimize its cell and module yerformance as a single or tandem junction technology. **!**

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SECTION 2.0 SECTION 2.0 **i**

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TF**S PROGRESS**

2.**¹ INT**RO**DUCTION** i

Activities related to thin film silicon:hydrogen alloy (TF**S**) focused on exploring large area (0.4 m²) thin film processing during Phase IIB. During this period, in order to reduce sources of electrical shunts, ^a _ _riety of process control advances were **m** established including acid washing of glass, air-borne particulate control, glass edging, better front ZnO uniformity and optimizing laser parameters for the front ZnO cell isolation. The film qualitie**s** of devices made at the Camarillo facility were shown to

be close to those made in the Chatsworth research !ab. **i**

2.**2 TFS DEVICE STR**U**C**TUR**E**

The basic device structure of both semitransparent TFS cells and modules is glass/ZnO/(graded dopant SiC p) $-i-(qraded$ dopant n) TFS/ZnO $[1-4]$. The $p-i-n$ TFS layers are deposited using a plasma discharge _rocess. Tables ²**-**¹ through 2-4 describe the TFS layer **|** compositions and thicknesses, typical TFS deposition conditions,
TFS layer properties, and ZnO properties. As discussed below, TFS layer properties, and ZnO properties. As discussed below,
these material properties result in state-of-the-art high efficiency devices. For example, p- and n-layer conductivities of 2.6 × 10⁵ and 3.5 × 10² respectively have been achieved [1]. No further optimization of the $p-$ and n-layers was pursued during this period since the TFS cell efficiency presently is controlled more **m** by the nature of the ZnO, the *i*-layer thickness, and by electrical shunting.

During Phase IIB, the measured performance of semitransparent TFS test structures improved to 10.8% efficiency (17.1 mA/cm² J_{sc}, 867 mV V_{oc}, 0.72 fill factor, 3.9 cm² active and total area) as shown in mv v_{oc}, 0.72 fill factor, 3.9 cm active and total area) as shown in the Bang Constant area as in the Bang Const
Fig. 2-1. This is due mainly to improved light trapping from the front ZnO. Previous analysis indicates that the I**s**o and efficiency increase by 10% if a back optical reflector is incorporated. Thus, the 10.8% efficiency for the semitransparent TFS cell is equivalent
to a 11.9% for a TFS device using a back optical reflector. As to a 11.9% for a TFS device using a back optical reflector. will be aescribed in Section 2.3, identification and removal of debris and contamination that shunt the TFS junctions has been the major focus of efforts to improve cell and module performance.

The large-area TFS module consists of 54 series-connected cells **i** with printed and fired silver paste buses near the edge of the glass (Fig. 2-2). The fabrication sequence for TFS modules, shown in Fig. 2-3, is similar to that for test cells except for the **i** patterning steps. The busbar contacts in the cells and modules are

Table 2-1. TFS cell $p/i/n$ layers.

Layer	Composition	Thickness	
Front ZnO p -layer i -layer n -layer Back ZnO	graded Si:C:H alloy doped with B standard, undoped Si: H alloy microcrystalline Si:H alloy doped with P	1.3 $0.010 \mu m$ $0.345 \mu m$ $0.030 \mu m$ 1.3	um μm

TFS deposition conditions; experimental
RF glow discharge reactor. Table $2-2$.

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B

Layer	D		n
$T(substrate)$, C p(total), torr Power Density, mW/cm2 $Q(Sih)$, sccm $Q(H_2)$, sccm $Q(CH_{\lambda})$, sccm $Q(B_2H_4)$, sccm $Q(PHz)$, sccm $Q(total)$, sccm Turn-over Time, sec	205 0.25 9.5 80 35 32 150 5	205 0.20 8.5 100 100	205 1.5 87.0 12 500 O Ω 515 10
Reactor Volume 52 liters Platen Area 1265 cm ²			

Table 2-3. TFS layer properties.

Transmittance**, 0**.3-0.9 _m 8**0**-8**5**% ,,**,**, _ I

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TFS cell fabricated in Camarillo. **I**

Table 2-4. Zin**c o**xide layer properties**.** I

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Fig. **2**-**3**. TFS module fabrication sequenc**e**, **i**

formed by firing a screen printed silver paste onto the glass substrate. Because the firin*g* temperatures are above 400°*C,* the conductor adhesion to glass is higher than the coh**e**sive strength of **B** the glass. The contact of the silver to zinc oxide is ohmic and stable. No evidence of instability or degradation has been found at this contact interface. The device performance uniformity for **i** ¹**×**⁴ ft TFS modules is mapped using ^a 3×12 array of I0×I0 cm test **m** structures that contain 2 rows of 8 cells each.

J **2.3 TFS PROCESSING PROGRESS**

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During the fourth quarter of 1908, all TFS activities were transferred to the Camarillo facility. The transfer revealed device performance sensitivities that required a variety of process control improvements. For example, semitransparent TFS devices are Shunts can be caused by laser patterning debris, dirty substrate static charge, and particulate contamination. Thus, sukstrate
cleanliness is critical to assure TFS process reliability.

> In Phase IIA, incoming glass was found to have "water marks" of
unknown composition that caused areas of unusua! ZnO growth. Studies found that water marks and their effects could be removed by pre**-**washing the glass substrates in acidic s**o**luti**o**ns (pH=3) [**2**].

l cleanliness is critical to assure TFS process reliability.

A second problem identified was static charge build-up on bare glass prior to transparent conductor deposition. The charged glass attracts particulates. Small glass shards on the glass substrate substrate during heating and shunt the TFS module. Using a pencil edg**e**r and then giving a thorough cleaning immediately after the uses a wet diamond wheel to grind a smooth radius edge. Figure 2-4 shows the improved cell yields using pen**c**il edgers compared to vbelt edgers for a 16-**c**ell test structure.

Other airborne particulates can also cause shunts in TFS junctions. I**o**nizing nitrogen guns and pulsed antistatic bars have been equipment to reduce particulate I installed contamination. Downflow hoods and plastic curtains have also bee installed at most process steps that take place before TFS deposition. Figure 2-5 identifies the particle counts at different processing stations under three conditions: (a) before installation of downflow hoods or curtains, (b) during production, and (c) whe there is no activity. As shown, the quiescent particle counts are substantially reduced by the downflow hoods and other upgrades, but the particle counts increase during actual processing. The Pl area where the front ZnO is scribed remains to be upgraded.

> The importance of TFS device shunting is evident in both the initial performance and in the outdoor exposure stability. The initial performan**c**e and in the outdoor exposure stability. The loss of module power with exposure is larger for lower initial resistances (less than about 1000 Ω -cm²) degrade by up to 35% after a month of outdoor exposure compared to less shunted devices, which
changed 20% or less. Almost all of the performance loss occurs in the first two weeks.

Module shunting was found to be the dominant power loss mechanism and thus was addressed first. Once the module shunt resistance is acceptably high, other loss mechanisms such as the Staebler-Wrons

Effect of pencil versus v-belt edger Fig. $2-4$. on yield of good TFS cells.

Fig. 2-5. Airborne particulate counts at various TFS process steps.

Shunt Resistivity (A.sq.cm)

effect then become controlling. For the state-of-the-art achieved in the Chatsworth research labs, the limits of these other mechanisms are on the order of $10-22$ loss (100 mW/cm², 200+ hours, Future advances in the materials and devices will further 50° C). reduce these loss mechanisms.

Process control improvements are needed in order to improve the uniformity of ZnO. Figures 2-7 through 2-10 are maps of the performance of a 1x4 ft area that show the PV parameters of individual 1x4 cm test structure cells made on a 1x4 ft glass plate. The blank spaces in the figures imply no test, usually due to poor electrical connections between the cell and the test fixture. As shown in Fig. 2-7, the lower right corner of the 1×4 area has lower V_{ac} 's. Figure 2-8 also shows a band of low currents is along the right side. The best efficiency is, of course, where both the J_{sc} and fill factor are high (Fig. 2-10). The lowest efficiency is near the edges where both deposition non-uniformity and handling impact performance. In addition, a band of shunted devices is present to the right of center. The average efficiency of all cells is 9.5%, which is equivalent to a 32.8 watt 1x4 ft module.

The optimal TFS and front ZnO thicknesses are different for the semitransparent TFS module for tandem compared to stand-alone TFS

Fig. 2-7. Map of TFS V_{oc} (volts) performance.

Fig. 2-8. Map of TFS J_{sc} (mA/cm²) performance.

Fig. 2-9. Map of TFS fill factor performance.

Fig. 2-10. Map of TFS efficiency performance.

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modules. This difference is in part to take advantage of the high performance and stability of the CIS module. To study performance trade-offs, the ZnO layers and the TFS i-layer of a group of modules were made thinner (230-280 nm versus 350 nm) to increase their optical transmission. Part of the group also had half the standard doping of the ZnO to further improve tiansmission. Figures 2-11 and 2-12 plot module power and slope at V_{oc} as functions of front ZnO thickness. The ranges in ZnO thickness functions of front ZnO thickness. listed reflect the variations measured across the individual 1×4 ft modules. The slope at V_{oc} provides an indication of module series modules. resistance as it impacts fill factor and thus power output. For the lower doped ZnO, the ZnO resistivity would be higher, resulting in higher ZnO sheet resistance which increases the overall module series resistance. This is reflected in the higher slopes at V_c
found in Fig. 2-12. For the standard doped ZnO, the ZnO For the standard doped ZnO, the ZnO contribution to module series resistance is reduced as reflected in the lower slopes at V_{oc}. This results in the higher module powers shown in Fig. 2-11.

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The thinner TFS *i*-layers (230-280 nm) had lower module outputs (3-4 watts less) on average than standard (350 nm) modules. CIS modules filtered by these thin modules gave 1-2 watts more than those filtered by standard TFS modules. Thus, the combined initial power for the TFS/CIS tandem module is less using the thin TFS i-layer compared to the standard *i*-layer. But the stabilized tandem power output using the thin TFS *i*-layer may exceed that of the tandem module using the standard TFS *i*-layer, depending on the relative stability of the respective TFS *i*-layers. It is expected that the thinner TFS i -layer module will be more stable. Further work is necessary to address these issues.

necessary to address these issues. **I**

2.4 TF3 CELL AND MODULE PERFORMANCE **2**.**4 TF**B **CELL AND MO**D**ULE PER**F**ORMA**N**CE i**

The p**article co**n**t**r**ol** impr**ov**e**me**n**ts i**n**st**a**lled i**n **the c**amar**illo** fa**cility h**a**ve i**n**c**rea**s**e**d the yielded** p**o**wer **o**f **i**x4 f**t** m**od**u**le**s as **i** demonstrated in Fig. 2-**1**3. **T**he average 1×4 ft TFS power output in February 1990 was 29.75 watts compared to 28.8 watts in August 1989. In addition, the distribution in module power was tighter in

February° **I** The best white-backed 1×4 ft module fabricated in Camaril generates 33.2 watts with a corresponding 8.4% aperture area efficiency as shown in Fig. 2-14. To evaluate the impact of scaling the module process from 1×1 ft to 1×4 ft, several 1×4 ft modules were cut into individual 1x1 ft module segments and the performances compared. Presently the 1x4 ft module efficiency Presently the 1×4 ft module efficiency
t 1×1 ft module piece cut from it. This averages 92% of the best 1×1 ft module piece cut from it. suggests that the best 1×4 ft module above might produce a best 1×1 ft module efficiency of 9.1% (8.4%+0.92), which compares well with the best 1x1 ft white-backed TFS module fabricated in Chatsworth with a 9.4% aperture area efficiency. The wider interconnects

Fig. $2-12$. Effect of ZnO thickness and doping on TFS V_{oc}.

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Aperture Area = 3970 cm^2 V_{oc} 47.35 volts \equiv 1.14 amps \equiv F_F^{sc} $=$ 0.614 Eff 8.4% \equiv \tilde{V}_{mp} \equiv 35.21 volts $\frac{1}{P_{\text{max}}^{\text{mp}}}$ 943.5 mA \equiv 33.2 watts \equiv

Fig. $2-14$. Best 1x4 ft TFS module fabricated in Camarillo.

(0.046 cm) used for the present 1×4 ft TFS modules versus 0.013 cm for the best i**×**i ft TFS module accounts for the difference in the 1x1 ft efficiencies. This indicates that the basic TFS junction fabrication process has been adequately transferred from Chatsworth to large-area processing equipment in Camarillo**0**

I In general, a comparison of the module cell Voc , Js**c**, and fill factor factor. Continued reductions in junction shunting with improve ments in particle control and better ZnO uniformity are expected to yield this improvement.

i **2**.**5 DISCUSS**I**O**N

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Emphasis during this period has been on the scaling of TFS module technology to 1×4 ft areas, resulting in demonstration of a 33.2 watt (8.4% aperture efficiency) back-reflector 54-celi module. Identifying and addressing several process sensitivities such as glass substrate quality and particulate control improved average and include power, outdoor stability, and performance distributions. Further improvements such as ZnO uniformity, particulate control at
the front ZnO patterning step, reduced electrical shunting, continued optimization of the layer thicknesses and doping, and narrower interconnects for the 1x4 ft modules will result in aperture efficiencies approaching 10%. Improved TFS junction Improved TFS junction quality, p marily through higher V_{oc}, will achieve module efficiencies exceeding 10%.

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SECTION 3.0 SECTION 3.0 **i**

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TANDEM PROGRESS

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TFS/CIS TANDEM CELL AND MODULE PERFORMANCE 3.1

Tandem modules are fabricated by laminating a semitransparent TFS
module onto a CIS module (Fig. 3-1). The glass/glass laminate module onto a CIS module (Fig. 3-1). construction provides ^a rugged, environmentally durable package. |

3_1 **TF**S/**CIS T**AN**DE**M **CELL** AN**D** M**ODUL**E **PERFOR**MA**NCE I**

The TFS/CIS tandem cell and module performance results achieved during the contract are summarized in Tables **3**-**1** through **3**-3**.** During Phase I, ^a 15.6% active area efficient TFS/CIS tandem cell m was demonstrated using a 10.3% semitransparent TFS and a 12.4% efficient CIS cell. In addition, a 12.3% aperture area efficient,
843 cm² 4-terminal TFS/CIS module was measured using a 7.7% 843 cm _ 4-terminal TFS/CIS m**o**dule was measure**d** using a 7.7% **I** : efficient semitransparent TFS module and a 7.6% effi**c**ient CIS module. The TFS-filtered CIS module contributed 2.7% efficiency to the tandem output, which is 35% of its stand-al**o**ne performance. The filtered CIS module output is primarily defined by its lower short-**c**ircuit current, which is 37% of its unfiltered value. During Phase IIB, the 33.2 wa**t**t TFS module (discussed in Section 2.3) without the white back reflector measured 30.2 watts or 7.6% **|** Placing a laminated 31.6 watt, 8.1% efficient CIS module underneath this TFS module, with an air gap between the two m modules, produced 11.2 watts or 2.9% over a 3883 cm² aperture area. Thus, the 4-terminal tandem power output is 41.4 watts, translating to 10.5% aperture efficiency. The TFS-filtered to unfiltered CIS power ratio of **0**.35 is dominated by a current ratio of 0.38**.**

Fig. **3-1**. TFS/CIS tandem module structure. **I**

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Table 3-1. 4-terminal tandem cell performance^a.

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I aMeasur_ **at** A**ST**M **ai**r _**ss 1.**5, **gl**o**bal 10**0 _/**c**m **2**, **2**5**°**C.

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Table 3-2. 1x1 ft tandem module performance^a.

Measu**re**d **a**t **A**S**T**M air mass **1**.5, **g**lobal **1**0**0** m_i**c**m2, 2**5**°C. **A**pertu**r**e a**r**ea.

Table 3-3. ix4 ft tandem module performance^a.

a
between at ASTM air mass 1.5, global 100 mW/cm², 25^oC.
papertific area.

I ;M**eas**ured at A**ST**M **a**ir **ma**ss 1.5, **g**lob**a**l 100 mg/**cm**2, 25°C.

3.2 LAMINATED AND FRAMED TFS/**CIS TAND**E**M 1**×**4 FT MODUL**E**S i**

F**iv**e 1×**4** f**t T**F**S** m**odu**l**e**s **were** s**elec**t**ed** f**o**r **tandem fronts. Three h**a**d** standard th**i**ckn**e**ss /-layers (**3**5**00** _) and tw**o**had thinner /**-**layers **i** (25**⁰⁰** A). The **^c**ompanion ^C**I**^S modules ranged from ³² to ³⁵ watts in ^M stand-alone mode. As discussed in Section 2.3, the thinner i-layer TFS modules are m**o**re transparent and typic**a**lly pr**o**duce **3-**4 watts less power themselves, but they allow the TFS-filtered CIS module to produce 1-2 watts more power.

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Pre-lamination measurements were made with an air gap. Postlamination measurements showed that less light was reflected back into the TFS and more was coupled into the CIS. modules became open circuited after the tandem package was framed. Framing was done in ^a reacti**o**ⁿ injecti**o**ⁿ mold (RIM). It is **m** believed that the electrical c**o**nnect**i**on between the external cable and the module bus ribbon becam**e o**pen-circuited during the RIM **i** framing process. **|**

I-V tests **o**n the Spire LAPSS at SER**I** were in go**o**d agreement (within m I% for two of the modules) with Siemens Solar LAPSS measurements (Table 3-4). The three tandem modules delivered to SERI had **|** maximum power between 35 and 36 watts. The close agree*ment between*
SERI and ARCO Solar measurements was established in Phase I.

Table 3-**4**. Measured power in watts of tandem modules. Table $3-4$.

SER**I** and AR**C**O Solar measurements was established in Phase I. **I**

3.**3 DISCUSSION**

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I The demonstration evolved during the contract from initial test cell structures to The demonstration of the high efficiency TFS/CIS tandem concept has ixl ft modules to ix4 ft modules. The larger s**i**ze is comparable to high efficiency thin film power product. Several issues have been identified for further development. Laminated and RIM framed 1×4
ft 4-terminal TFS/CIS tandem modules have been delivered to SERI I for evaluation. The state of \mathbb{R}^n tandem modules have been delivered to SERII and SE

> The future performance of TFS/CIS tandem modules has been modeled.
Tandem modules with 17.2% aperture-area efficiency generating 67 watts on an area of 3900 cm² are projected when junction efficiency and module fabrication goals are achieved (Table 3-5). In the and module fabrication goals are achieved (Table 3-5). In the tandem module stack, the semitransparent TFS module contributes **I** tall at tandem 44.4 watts or 11.4% efficiency, and the CIS module contributes 22.6 watts or 5.8%. The stand-alone CIS module would generate 51.6 watts or 5.8%. The stand-alone CIS module would generate 51.6
watts or 13.3%.

i The model accu The model assumes a TFS optical filter factor (filtered-to-standalone CIS photocurrent ratio) of 0.46. The CIS module performance assumes a 14.1% junction efficiency already demonstrated on 3.5 cm^2 **I** assumes a 14.2). The TFS module performance assumes 17.5 mA/cm² cells with 12.0% efficiency, 17.7 mA/cm² J_{ss}, and 965 V_{ss} [1] and **i** constant the contraction of the constant $\frac{1}{2}$ and $\frac{1}{2}$ $\frac{1}{2}$ $\frac{1}{2}$ matrix $\frac{1}{2}$ and $\frac{1}{2}$ $\frac{1}{2}$ matrix $\frac{1}{2}$ reported.

Table **3-5**. Projected **T**FS/CIS tandem module perf**o**rmance.

aASTM air mass 1.5, global 100 mW/cm², 25°C.
DAperture area.

I bAperture are**a**. '

SECTION 4.0

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PAPERS PUBLISHED DURING PHASE IIB

PAPER**S PUBLISHED DURING PHAS**E **I**I**B i**

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The f**o**llowing papers and reports have been produced under SERI **g** Subcontract ZB-7-06003-3, titled "Research on Efficiency, Large-Area, Amorphous Silicon Based Submodules." **I**

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